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CONFIRMATION NO. 4125

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| SERIAL NUMBER 10/668,186 | FILING OR 371(c) DATE 09/24/2003 RULE | CLASS 257 | GROUP ART UNIT 2813 | ATTORNEY DOCKET NO. 1248-0673P |
| APPLICANTS Yutaka Takafuji, Nara-shi, JAPAN; Takashi Itoga, Nara-shi, JAPAN; | | | | |
| ** CONTINUING DATA ***** | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2002-280078 09/25/2002 JAPAN 2002-299577 10/11/2002 JAPAN 2003-067109 03/12/2003 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/20/2003 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> Examiner's Signature Initials | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 17 | TOTAL CLAIMS 56 |
| | | | INDEPENDENT CLAIMS 14 | |
| ADDRESS 2292 | | | | |
| TITLE Single-crystal silicon substrate, SOI substrate, semiconductor device, display device, and manufacturing method of semiconductor device | | | | |
| FILING FEE RECEIVED 2772 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |